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CONFIRMATION NO. 4132

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| SERIAL NUMBER<br>10/791,930 | FILING DATE<br>03/03/2004<br><br>RULE | CLASS<br>700 | GROUP ART UNIT<br>2125 | ATTORNEY<br>DOCKET NO.<br>24061.49 |
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\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 05/21/2004

|  |  |                               |                        |                       |                            |
|--|--|-------------------------------|------------------------|-----------------------|----------------------------|
| Foreign Priority claimed<br>35 USC 119 (a-d) conditions met<br>Verified and Acknowledged | <input type="checkbox"/> yes <input checked="" type="checkbox"/> no<br><input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after<br><i>Allowance</i><br>Examiner's Signature Initials | STATE OR<br>COUNTRY<br>TAIWAN | SHEETS<br>DRAWING<br>6 | TOTAL<br>CLAIMS<br>20 | INDEPENDENT<br>CLAIMS<br>3 |
|--|--|-------------------------------|------------------------|-----------------------|----------------------------|

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TITLE  
 System and method for process contamination prevention for semiconductor manufacturing

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|------------|---|--|
| FILING FEE | FEES: Authority has been given in Paper<br>No. _____ to charge/credit DEPOSIT ACCOUNT | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) |
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